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**CONFIRMATION NO. 8963** 

SERIAL NUMBE F 09/936,683			CLASS 257		GROUP ART UNIT 2826		ATTORNEY DOCKET NO. 213578		
APPLICANTS  Kazuyuki Tadatomo, Hyogo, JAPAN;  Hiroaki Okagawa, Hyogo, JAPAN;  Yolchiro Ouchi, Hyogo, JAPAN;Masahiro Koto, Hyogo, JAPAN;  *** CONTINUING DATA ******  This application is a 371 of PCT/JP00/01588 03/15/2000  *** FOREIGN APPLICATIONS *****  JAPAN 72133/1999 03/17/1999  JAPAN 335591/1999 11/26/1999  JAPAN 3356421/1999 11/26/1999  JAPAN 353044/1999 12/13/1999									
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged  ADDRESS 23460 LEYDIG VOIT & MAYER, LTD TWO PRUDENTIAL PLAZA, SUITE 4900 180 NORTH STETSON AVENUE CHICAGO, IL 60601-6780									
TITLE SEMICONDUCTOR BASE AND ITS MANUFACTURING METHOD, AND SEMICONDUCTOR CRYSTAL MANUFACTURING METHOD									
l N	No to charge/credit DEPOSIT ACCOUNT RECEIVED No for following:					All Fees  1.16 Fees ( Filing )  1.17 Fees ( Processing Ext. of time )  1.18 Fees ( Issue )  Other  Credit			